



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Naoto Kusumoto et al.
Serial No. : 10/602,762
Filed : June 25, 2003
Title : LASER ANNEALING METHOD

Art Unit : Unknown
Examiner : Unknown

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Supplemental to an information disclosure statement filed June 25, 2003, Applicants submit the instant information disclosure statement to properly identify a reference earlier cited. Under 35 USC §120, this application relies on the earlier filing date of application serial number 08/594,670, filed on February 2, 1996. The attached Form PTO-1449 lists a reference which was submitted to and/or cited by the Office in the prior application and, therefore, is not provided in this application.

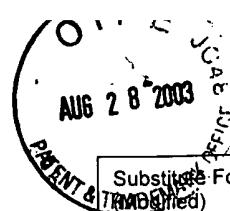
This statement is being filed within three months of filing the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,


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Date: August 28, 2003

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Sheet 1 of 1

Substitute Form PTO-1449
TM-03-04

U.S. Department of Commerce
Patent and Trademark Office

Attorney's Docket No.
07977-004002

Application No.
10/602,762

**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

(37 CFR §1.98(b))

Applicant
Naoto Kusumoto et al.

Filing Date
June 25, 2003

Group Art Unit

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AJ							
	AK							
	AL							
	AM							
	AN							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AO	Brotherton et al.; "Beam shape effects with EL crystallization of...a-Si"; <i>Solid State Phenomena</i> , Vol. 37-38; pp. 209-304; 1994

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Disclosure Form (PTO-1449)